

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

| | | |
|------------------------|---------------------|--|
| Application Number | 10613495 | |
| Filing Date | 2003-07-02 | |
| First Named Inventor | Tienteh Chen et al. | |
| Art Unit | 1774 | |
| Examiner Name | P. Schwartz | |
| Attorney Docket Number | 200209928-1 | |

| | | | | | | | | |
|------------|---|---------|----|----|------------|-------------------------|-------------------------------------------------------------------------------------|--------------------------|
| <i>PRJ</i> | 1 | 0878319 | EP | B1 | 2001-10-24 | Felix Schoeller jr Foto |  | <input type="checkbox"/> |
| <i>PRJ</i> | 2 | 1048478 | EP | A2 | 2000-11-02 | Toyo Boseki Kabushiki |  | <input type="checkbox"/> |

If you wish to add additional Foreign Patent Document citation information please click the Add button

NON-PATENT LITERATURE DOCUMENTS

| | | | |
|--------------------|---------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------|
| Examiner Initials* | Cite No | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published. | T5 |
| <i>PRJ</i> | 1 | European Search Report for EP 1 493 592 A3, dated October 13, 2005. | <input type="checkbox"/> |

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature *P Schwartz* *PRJ* Date Considered *8/27/07*

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

| | | |
|--------------------------------------------------------------------------------------------------------|------------------------|---------------------|
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Not for submission under 37 CFR 1.99)</i> | Application Number | 10613495 |
| | Filing Date | 2003-07-02 |
| | First Named Inventor | Tienteh Chen et al. |
| | Art Unit | 1774 |
| | Examiner Name | P. Schwartz |
| | Attorney Docket Number | 200209928-1 |

| U.S.PATENTS | | | | | | Remove |
|-------------------|---------|---------------|------------------------|------------|-------------------------------------------------|--------------------------------------------------------------------------|
| Examiner Initial* | Cite No | Patent Number | Kind Code ¹ | Issue Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear |
| PRJ | 1 | 4438170 | | 1984-03-20 | McCue | |
| PRJ | 2 | 5451559 | | 1995-09-19 | Smith et al. | |
| PRJ | 3 | 5863648 | | 1999-01-26 | Ohmura et al. | |

If you wish to add additional U.S. Patent citation information please click the Add button.

| U.S.PATENT APPLICATION PUBLICATIONS | | | | | | Remove |
|-------------------------------------|---------|--------------------|------------------------|------------------|-------------------------------------------------|--------------------------------------------------------------------------|
| Examiner Initial* | Cite No | Publication Number | Kind Code ¹ | Publication Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear |
| PRJ | 1 | 20040066439 | A1 | 2004-04-08 | Kasperchik et al. | |
| PRJ | 2 | 20050003112 | A1 | 2005-01-06 | Chen | |

If you wish to add additional U.S. Published Application citation information please click the Add button.

| FOREIGN PATENT DOCUMENTS | | | | | | | Remove | |
|--------------------------|---------|--------------------------------------|---------------------------|------------------------|------------------|-------------------------------------------------|--------------------------------------------------------------------------|----------------|
| Examiner Initial* | Cite No | Foreign Document Number ³ | Country Code ² | Kind Code ⁴ | Publication Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear | T ⁵ |